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ATTORNEY'S DOCKET NO. NECW 18.281

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toru TATSUMI, et al.

Application No.: 09/744,701

Filed: January 29, 2001

For: METHOD OF VAPOR PHASE
GROWTH OF METAL OXIDE
DIELECTRIC FILM AND APPARATUS
FOR VAPOR PHASE GROWTH OF
METAL DIELECTRIC MATERIAL

Group Art Unit: 2812

Examiner: H. Jey TSAI

Date: September 17, 2003

TECHNOLOGY CENTER 2800

SEP 25 2003

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In response to the Office Action dated March 17, 2003, the period for responding thereto expiring after June 17, 2003, the period for responding thereto not being extended for more than three months, kindly amend the above-identified application as follows: